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Docket No.: OMY-013  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Kunie Ogata et al.

Application No.: 09/963,527

Group Art Unit: 1756

Filed: September 27, 2001

Examiner: J. Ruggles

For: RESIST PATTERN FORMING METHOD  
(amended)

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated October 8, 2003 (Paper No. 10), finally rejecting claims 16-29, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.

An **Appendix** including a substitute specification is attached following page 21 of this paper.